

Docket No. 1514.1032

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Ji Yong PARK et al.

Application No. 10/690,507

Group Art Unit: 1792

Confirmation No. 6043

Filed: October 23, 2003

Examiner: Matthew J. Song

For: METHOD FOR MANUFACTURING POLYCRYSTALLINE SILICON THIN FILM AND
THIN FILM TRANSISTOR FABRICATED USING POLYCRYSTALLINE SILICON THIN
FILM MANUFACTURED BY THE MANUFACTURING METHOD

REQUEST FOR REFUND

Mail Stop 16
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

On March 29, 2007, a Request for Continued Examination (RCE) including a petition for a two-month extension of time was filed in the above-identified application together with a credit card payment form authorizing a payment of \$1,240.00, which included the RCE filing fee of \$790.00 and the two-month extension of time fee of \$450.00. Attached hereto is a copy of page 7 of an American Express credit card statement with a closing date of March 30, 2007, showing that the payment of \$1,240.00 was posted to American Express credit card account number [REDACTED] 71008 on March 29, 2007.

However, \$120.00 of the \$450.00 two-month extension of time fee had already been paid in connection with the petition for a one-month extension of time in the Reply/Amendment Fee Transmittal filed on February 28, 2007, with the Amendment After Final Rejection of February 28, 2007. Accordingly, only the additional extension of time fee of \$330.00 for the second month (i.e., \$450.00 - \$120.00 = \$330.00) was required for the petition for a two-month extension of time filed on March 29, 2007, meaning that an excess fee of \$120.00 was paid on March 29, 2007. Accordingly, pursuant to 1.26(a) and MPEP 607.02, it is respectfully requested

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that the Office refund the excess fee of \$120.00 by crediting it to the credit card account to which it was charged, i.e., to American Express credit card account number [REDACTED] 71008, expiration date 12/09, in the name of Michael D. Stein of Stein, McEwen & Bui, LLP.

Respectfully submitted,

STEIN, MCEWEN & BUI, LLP

Date: 10/09/08
By: Randall S. Sviha
Randall S. Sviha
Registration No. 56,273

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Washington, D.C. 20005
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Attachment

Oct. 9, 2008 4:44PM Stein McEwen and Bui LLP

No. 6657 P. 3



Prepared For
MICHAEL D STEIN
STEIN MCEWEN BUI LLP

Account Number
71008

Closing Date
03/30/07

Page 7 of 7

Activity Continued	Reference Code	Amount \$
03/28/07 US PATENT TRADEMARK 571-2726500 VA REF# 10995295 GOVERNMENT SERVI 03/28/07	10995295000	180.00
03/28/07 US PATENT TRADEMARK 571-2726500 VA REF# 11285124 GOVERNMENT SERVI 03/28/07	11285124000	180.00
03/28/07 US PATENT TRADEMARK 571-2726500 VA REF# 10418300 GOVERNMENT SERVI 03/28/07	10418300000	180.00
03/28/07 US PATENT TRADEMARK 571-2726500 VA REF# 11692407 GOVERNMENT SERVI 03/28/07	11692407000	1,000.00
03/28/07 US PATENT TRADEMARK 571-2726500 VA REF# 11692455 GOVERNMENT SERVI 03/28/07	11692455000	1,550.00
03/28/07 US PATENT TRADEMARK 571-2726500 VA REF# 11692509 GOVERNMENT SERVI 03/28/07	11692509000	1,000.00
03/28/07 US PATENT TRADEMARK 571-2726500 VA REF# 11692514 GOVERNMENT SERVI 03/28/07	11692514000	1,000.00
03/28/07 US PATENT TRADEMARK 571-2726500 VA REF# 11692520 GOVERNMENT SERVI 03/28/07	11692520000	1,450.00
03/28/07 US PATENT TRADEMARK 571-2726500 VA REF# 11692533 GOVERNMENT SERVI 03/28/07	11692533000	1,150.00
03/28/07 US PATENT TRADEMARK 571-2726500 VA REF# 11692617 GOVERNMENT SERVI 03/28/07	11692617000	1,400.00
03/29/07 US PATENT TRADEMARK 571-2726500 VA REF# 10690507 GOVERNMENT SERVI 03/29/07	10690507000	1,240.00
03/29/07 US PATENT TRADEMARK 571-2726500 VA REF# 11693166 GOVERNMENT SERVI 03/29/07	11693166000	1,500.00
Total for MICHAEL D STEIN	New Charges/Other Debits Payments/Other Credits	123,775.00 -69,605.00

03/29/07 10:44:00 AM - 03/29/07 10:44:30 AM

Electronic Patent Application Fee Transmittal

Application Number:	10690507			
Filing Date:	23-Oct-2003			
10/17/2008 SDIRETA1 00000014 10690507 01 FC:1252 330.00 gp				
Title of Invention:	Method for manufacturing polycrystalline silicon thin film and thin film transistor fabricated using polycrystalline silicon thin film manufactured by the manufacturing			
Refund Ref: 10/17/2008 0030062464				
Credit Card Refund Total: \$120.00				
Am Exp. First Name: Ji Yong Park Last Name: Park Applicant Name:	Ji Yong Park			
Filer:	Hung H. Bui/Karen Jones			
Attorney Docket Number:	1514.1032			
Filed as Large Entity				
Utility Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				
Extension - 2 months with \$0 paid	1252	1	450	450

Adjustment date: 10/17/2008 SDIRETA1
 03/29/2007 INTEFSW 00002181 10690507
 01 FC:1252 -450.00 GP

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Request for continued examination	1801	1	790	790
Total in USD (\$)				1240